

PATENT Customer No. 22,852 Attorney Docket No. 04329.2558

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE		
In re Application of:	)	
Naoya HAYAMIZU, et al.	) Group Art Unit: 174	,6
Application No.: 09/817,197	) Examiner: Markoff,	Alexander 2
Filed: March 27, 2001	)	
For: WASHING METHOD, METH MANUFACTURING SEMICONDUCTOR DEVICE METHOD OF MANUFACTU ACTIVE MATRIX-TYPE DIS DEVICE	AND ) RING )	
Assistant Commissioner for Patents Washington, DC 20231 Sir:	02/03/2003 SZENDIE1 00000049 0989 01 FC:1201 02 FC:1202 03 FC:1251	17197 420.00 OP 342. <del>90</del> OP 110.50 OP 1700

In reply to the Office Action dated October 2, 2002, with a period for response extending through February 3, 2003 (by the attached Petition for Extension of Time of One Month and requisite fee payment, and February 2<sup>nd</sup> being a Sunday), please amend the application as follows:

## IN THE CLAIMS:

Please amend claims 1, 2, 5-8, 12, 19, and 20, and add new claims 24-42, as follows:

FINNEGAN HENDERSON FARABOW GARRETT & DUNNER LLP

. 1300 I Street, NW Washington, DC 20005 202.408.4000 Fax 202.408.4400 www.finnegan.com 1. (Twice Amended) An ultrasonic washing method of washing a thing to be washed by supplying ultrasonic-wave-applied cleaning fluid to the thing, said ultrasonic washing method comprising applying an ultrasonic wave to a cleaning fluid in such a manner that said ultrasonic